

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

MARK B. FUSELIER
DERICK J. WRISTERS
ANDY C. WEI

Confirmation No.: 9406

Group Art Unit: 2811

Serial No.: 10/821,230

Examiner: Ori Nadav

Filed: April 8, 2004

Att'y Docket: 2000.092182/TT5077D

For: SEMICONDUCTOR DEVICE FORMED
OVER A MULTIPLE THICKNESS
BURIED OXIDE LAYER, AND
METHODS OF MAKING SAME

Customer No.: 23720

RESPONSE TO OFFICE ACTION DATED NOVEMBER 13, 2007

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This paper is submitted in response to the Office Action dated November 13, 2007, for which the three-month date for response is February 13, 2007.

It is believed that no fee is due; however, should any fees under 37 C.F.R. §§ 1.16 to 1.21 be required for any reason, the Commissioner is authorized to deduct said fees from Williams, Morgan & Amerson's P.C. Deposit Account 50-0786/2000.092182.

Remarks begin on page 2 of this paper.

Reconsideration of the application is respectfully requested.